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Asymmetric carrier transport and weak localization in few layer graphene grown directly on a dielectric substrate†

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Temperature-dependent electrical and magneto-transport measurements have been performed on devices composed of few layer (4L) graphene grown directly on SiO₂/Si substrates using the CVD method. An intrinsic energy band-gap of 4.6 meV in 4L graphene is observed, which primarily dictates the current transport at $T < 50$ K. Unusual temperature dependent electron–hole conduction asymmetry is observed at $T > 50$ K, which can be explained in the framework of the defect scattering of relativistic charge carriers. Magneto-transport measurements reveal a weak localization effect sustainable till $T > 200$ K. The coexistence of phonon mediated carrier mobility and defect induced weak localization effects in measuring devices suggests low disorder and impurity scattering.

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Introduction

Graphene has attracted tremendous interest because of its remarkably high electron mobility^{1,2} and mechanical strength.³ These superior qualities may enable it to be used in next generation electronics. However, mainstream technological usage requires mass production of large-area graphene with high carrier mobility. For example, the mechanical exfoliation of graphite produces high-quality graphene with ultra-high electron mobility,^{1,4} but the large area and mass production remain heavily compromised.⁵ In contrast, the chemical vapour deposition (CVD) on metal films produces a large area of graphene. However, transferring the synthesized graphene to dielectric substrates severely deteriorates the electron mobility due to wrinkles and chemical contamination.⁶ Although there are several other growth methods, having all the required features (mass production, large-area, high carrier mobility *etc.*) together remains challenging. It places a constraint on the possibility of graphene-based technology becoming a reality in the way theoretically predicted. To circumvent this long standing issue, many researchers have recently

focused on the direct growth of graphene on dielectric substrates which avoids the complicated transfer procedure (from metal to dielectric substrates) and associated side effects. Subsequently, considerable improvement in carrier mobility could be expected and thus it could enable us to achieve all the parameters required for future technological use of graphene as mentioned earlier.

Direct growth of graphene on dielectric substrates has been previously studied, however, most of the reports have discussed mainly about the growth mechanism and the quality of graphene films has been mainly probed using non-invasive optical methods such as Raman spectroscopy, X-ray photoelectron spectroscopy and room temperature electrical measurements.^{7,8} Although these reports provide a good insight into the growth mechanism, a quantitative investigation of the properties of directly grown graphene *via* electrical measurements has been lacking so far. Such an experimental study could pave the way for much awaited technological advancement driven by high quality graphene produced on a large scale by the direct growth of graphene layers on dielectric substrates *via* CVD. Hence, a comprehensive experimental study is still vital in order to provide better understanding of the intrinsic electronic features of devices comprising graphene grown directly on dielectric substrates using the CVD method. Here, in this letter, we explore the properties of such devices *via* temperature dependent electrical/magneto-transport measurements. A series of gate and temperature dependent measurements indicate the appearance of an intrinsic energy bandgap in few layer graphene (FLG) grown directly on SiO₂/Si substrates using CVD. The intrinsic energy bandgap is found to dictate the temperature dependent current-transport such as electron–hole

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conduction asymmetry. Magneto-transport measurements on these devices exhibit a weak localization (WL) effect which sustains till 200 K. Furthermore, simultaneous observation of phonon mediated carrier mobility and WL in our devices suggests moderate disorder in as-grown FLG.

Experimental

CVD growth of graphene

Graphene was directly grown on a SiO₂ substrate by the thermal CVD process using Cu vapour as catalyst. In a typical experiment, a Cu foil was placed in a quartz tube beside the SiO₂ substrate at a certain distance and the growth was performed at 1020 °C in the presence of an Ar, H₂ and CH₄ mixture at atmospheric pressure (ESI,† Fig. S1). Before synthesis, the Cu foil cut into 2 cm × 2 cm dimension (0.025 mm (0.001 in) thick, 99.9% from Alfa Aesar) was cleaned by dipping in etchant solution (FeCl₃ (20 mL) + HCl (20 mL) in 200 mL DI water) for 10 s, subsequently rinsed with DI water several times and dried by N₂ flow. SiO₂ substrates cut into 2 cm × 2 cm dimension were cleaned in an ultrasonic bath with acetone, IPA and DI water for 10 minutes each and dried by N₂ flow.

HRTEM

TEM analysis was performed by first spin coating PMMA A950 for 60 s at 3000 rpm on directly synthesized graphene on a SiO₂ substrate cut into a 1 cm × 1 cm area and left overnight. PMMA from each side of the sample was removed using a sharp blade and the sample was immersed in BOE solution overnight and subsequently rinsed with DI water several times. The floating PMMA/Gr was transferred onto a Cu grid (Quanta foil), kept in acetone for 2 h for PMMA removal, and rinsed with IPA followed by drying using CPD. High resolution TEM images and SAED patterns were obtained using JEOL ARM 200 F with a Cs-corrected field emission gun TEM. For the cross-section thickness measurement, FIB was performed on Gr/SiO₂.

Raman spectroscopy

Raman spectroscopy was performed using a WITech GmbH confocal spectrometer equipped with a 50 × objective lens and a laser wavelength of 532 nm. We first performed calibration of the spectra with the Si peak at 520 cm⁻¹ using 1 mW laser power to avoid sample heating. A large area (100 × 100 μm²) Raman map was acquired using similar conditions.

XPS

Chemical composition and bonding states were analysed using XPS ESCALAB 220i-XL (VG Scientific Instruments) with an Al Kα X-ray source.

Device fabrication and data acquisition

Hall bar geometry was prepared by e-beam lithography using PMMA as an etch mask. Directly grown graphene was etched in O₂ plasma (5 sccm (O₂ flow), for 20 s (exposure time), at 20 Watts (Plasma power)) to define a channel length of 5 μm

and a width of 6 μm (ESI,† Fig. S2). The metal electrodes (Cr/Au 10/70 nm) were deposited using an e-beam evaporator at a base pressure of 10⁻⁷ mbar. A low temperature cryostat (Cryomag-netics Inc. Oak Ridge USA) was used for hall measurements. A standard lock in technique was used to record all transport measurements.

Results and discussion

We first characterized the FLG grown directly on SiO₂ substrates *via* CVD (for the growth procedure, see the ESI†). Fig. 1a shows high resolution transmission electron microscopy (HRTEM) images of graphene layers and the corresponding selected area electron diffraction (SAED) pattern. Complete flat coverage with connected graphene clusters is clearly visible. The SAED pattern shows a set of hexagonal diffraction spots confirming the single crystalline nature of graphene.⁹ Cross sectional HRTEM (Fig. 1b) imaging was performed to determine the thickness, which comes out to be 1.5 nm (~4L). In order to further verify the chemical composition and bonding states in graphene, X-ray photoelectron spectroscopy (XPS) was carried out. The survey spectrum in the inset of Fig. 1c shows distinct peaks of O 2s (binding energy, BE: 26.5 eV), Si 2p (104.6 eV), Si 2s (155.02 eV), and O 1s (543) from SiO₂ substrates where the C 1s (284.6 eV) peak is attributed to graphene. Since the carbon 1s peak ranges from 284 eV to 289 eV, its deconvolution is important to understand whether there is any hidden residual peak as shown in Fig. 1c. The Gaussian fitted peaks of C 1s comprise 3 distinct peaks centred at 284.5 eV, 285.6 eV and 288.9 eV respectively. The peak at 284.5 eV can be attributed to the C 1s peak of sp² C-C which makes the graphene 2D peak appear. Peaks at 285.6 and 288.9 correspond to the sp³ source of carbon and could be responsible for the D peak in the Raman spectrum.¹⁰ The relative content of carbon in our graphene devices estimated from the area under the curve of Gaussian fit XPS Peak 1 (green) related to the sp² carbon is 72% whereas that of Peak 2 (red) and Peak 3 (purple) related to sp³ carbon is 28% respectively. Interestingly, we did not observe any residual peak related to Cu 2s (1096.5 eV), Cu 2p (3/2) (932–943 eV) and Cu 3p (75.10–75.14 eV) or any other possible residue in the survey spectrum. This illustrates the clean basal plane of FLG grown directly on SiO₂/Si surfaces *via* CVD.

The Raman spectrum shown in Fig. 1d clearly indicates the signature of FLG with finite disorder density evident as the D peak. The intensity ratio of Raman G (IG) and D peaks (ID) falls around 0.60, which indicates moderate disorder in the graphene sample. Fig. 1(e and f) show Raman maps for intensity ratios *i.e.* I_D/I_G and I_{2D}/I_G. The I_D/I_G map clearly indicates the uniform distribution of disorders in the 100 μm × 100 μm area. However, I_{2D}/I_G ≤ 1 in most of the regions indicates uniform growth of few layer graphene all over the mapped region. The estimated defect density n_D and average distance between defects L_D in our graphene devices are 1.8 × 10¹¹ cm⁻² and 14 nm respectively (details in the ESI†).

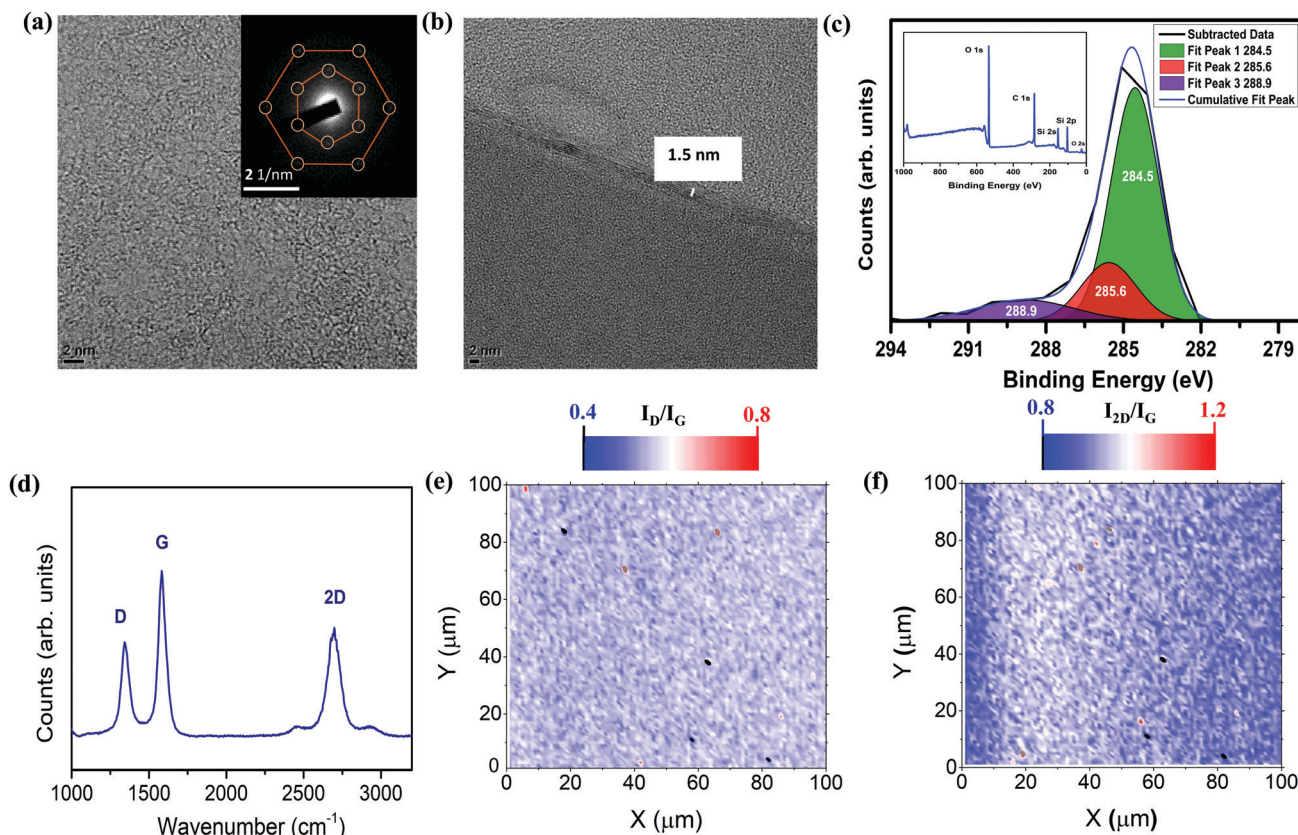


Fig. 1 Graphene synthesis and characterization. (a) Transmission electron microscopy (TEM) image of the basal plane of graphene. The inset shows the selected area electron diffraction pattern. (b) Cross sectional TEM image with a graphene thickness of 1.5 nm ($\sim 4L$). (c) C 1s X-ray photoelectron spectroscopic data (de-convoluted) taken on graphene. The inset shows the survey spectrum. (d) Raman spectrum of 4L graphene (D, G and 2D peaks and the corresponding ratios are labelled). (e) and (f) I_D/I_G and I_{2D}/I_G intensity ratio maps acquired on a $100 \mu\text{m} \times 100 \mu\text{m}$ area (I_D , I_G and I_{2D} are intensities corresponding to D, G and 2D Raman peaks, respectively).

After characterizing the graphene layers, we carried out transport measurements on Hall bar devices in the geometry as shown in Fig. 2a. Fig. 2b shows longitudinal resistance (R_{xx}) as a function of back gate (V_G) at various temperatures in the range of $6.5 \text{ K} < T < 250 \text{ K}$. The position of the charge neutral point (CNP) in the positive VG regime is an indication of p-doped graphene layers. Two observations could be made from these temperature dependent data, (i) the value of the maximum resistivity increases at low temperature and (ii) the CNP shifts to higher positive VG at low temperature. Both of these observations have close resemblance to the characteristics reported for dual gated few bi-/trilayer graphene devices where a finite vertical displacement field leads to symmetry breaking,¹¹ leading to the CNP shift and opening of an energy bandgap. Fig. 2c shows the Arrhenius plot for minimum conductivity values as a function of temperature, expressed as $\ln \sigma = \Phi/(k_B T)$ where Φ and $k_B T$ are the thermal activation energy and Boltzmann constant, respectively. The activation energy in the FLG device corresponds to an energy bandgap which comes out to be 4.6 meV. Such an intrinsic bandgap in directly grown (on the SiO_2/Si substrate) FLG is attributed to the substrate effect, which could be reconciled with a recent theoretical report where it has been predicted that the substrate-induced

potential can break the honeycomb lattice symmetry and generate an energy bandgap.¹²

The shift of the CNP with temperature is quantitatively summarized in Fig. 2d. The shift clearly indicates the increased p-doping in few-layer graphene at low temperature. This observation is also supported by reduced electron Hall density, n , at low temperatures as shown in the inset of Fig. 2d. Interestingly, the CNP and n both remain temperature independent in the range of $53 \text{ K} < T < 250 \text{ K}$ and a substantial increase (decrease) in CNP (n) starts below 53 K ($\sim 4.6 \text{ meV}$). As soon as the thermal energy is reduced below 4.6 meV, the effect of the energy bandgap comes into picture, which manifests the effect of the energy bandgap (4.6 meV) on current-transport in our devices. A significant impact of thermally activated transport below $T = 53 \text{ K}$ is not only limited to the CNP shift and reduction in n , but also leads to the temperature dependent electron-hole conduction asymmetry,¹³ which is manifested as the deviation of hole and electron mobilities (μ_h and μ_e , respectively) from $\mu_h/\mu_e = 1$. Fig. 2e summarizes temperature dependent hole and electron mobilities determined from Hall measurements. Ten-fold enhancement in the electron mobility of $\sim 600 \text{ cm}^2 \text{ V s}^{-1}$ at 6.5 K indicates phonon dominated transport and good quality of directly grown FLG on SiO_2/Si substrates. Interestingly, there

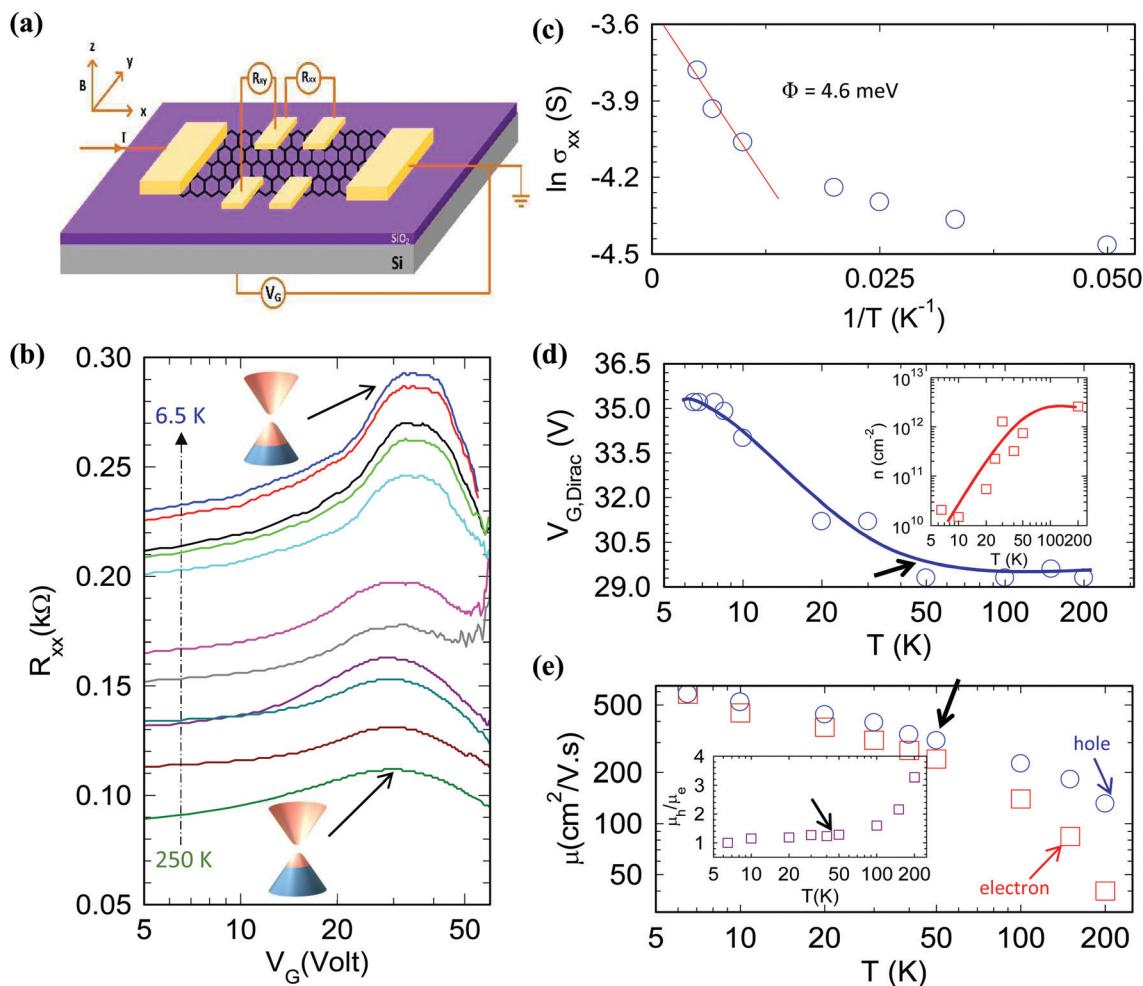


Fig. 2 Temperature dependent transport measurements and electron–hole conduction asymmetry. (a) Optical image of the measured device with contact details. (b) Gate dependent longitudinal resistance measured in the temperature range as labelled. The insets show the schematic illustration of the Fermi level position at 250 K and 6.5 K. (c) Arrhenius plot taken from temperature dependence of minimum conductivity points from panel (b). Estimated thermal activation energy is ~ 4.6 meV. (d) Shift in resistivity peaks (Dirac point) as a function of temperature. A sharp increase in gate bias corresponding to Dirac points below 4.6 meV (53 K) can be seen (arrow indicates $T = 53$ K). The inset shows the temperature dependence of Hall electron density expressed as $n = -1/e \times dR_{xy}/dB$. (e) Temperature dependent hole (μ_h)/electron (μ_e) mobilities with evident asymmetry beyond $T = 53$ K (4.6 meV). The inset shows temperature dependent evolution of the magnitude of the mobility ratio (μ_h/μ_e).

is a small conduction asymmetry, *i.e.* $\mu_h/\mu_e \sim 1.25$, below $T = 53$ K. However, at $T > 53$ K, conduction asymmetry diverges and reaches up to 3.3. Beyond $T = 53$ K, the conduction asymmetry evolves as $\mu_h/\mu_e \propto T^{0.6}$. Such a striking difference in asymmetry below and above the energy bandgap could be qualitatively understood in the framework of relativistic/non-relativistic carriers.¹³

At $T > 53$ K, carriers will have enough thermal energy to overcome the energy bandgap. Hence, in the range of $53 \text{ K} < T < 250 \text{ K}$, FLG will behave more like a gapless semiconductor which facilitates relativistic Fermi velocity due to unique band dispersion. In this view, current-transport will be explained in the framework of the relativistic nature of carriers in FLG. In recent experimental and theoretical reports, it has been established that in contrast to a non-relativistic quantum system, the scattering cross section in a relativistic quantum system does

depend on the sign of scattering potential and could be expressed as^{13,14}

$$\frac{\mu_h}{\mu_e} = \frac{n_i^+ C(-\alpha) + n_i^- C(+\alpha)}{n_i^+ C(+\alpha) + n_i^- C(-\alpha)} \quad (1)$$

Here, α is the impurity strength, and n_i^+ , n_i^- are the positive and negative impurity density, respectively. Hence, in the framework of the relativistic system, electrons will be scattered off strongly as compared to holes from a donor impurity. This is consistent with $\mu_h/\mu_e > 1$ as observed in our devices at $T > 53$ K. However, at $T < 53$ K, the thermal energy will be smaller as compared to the energy band gap. Due to lack of the thermal activation of carriers below 50 K, it leads to two orders of magnitude decrease in electron density at 6.5 K as shown in Fig. 2d. Such a reduction in carrier density would naturally lead

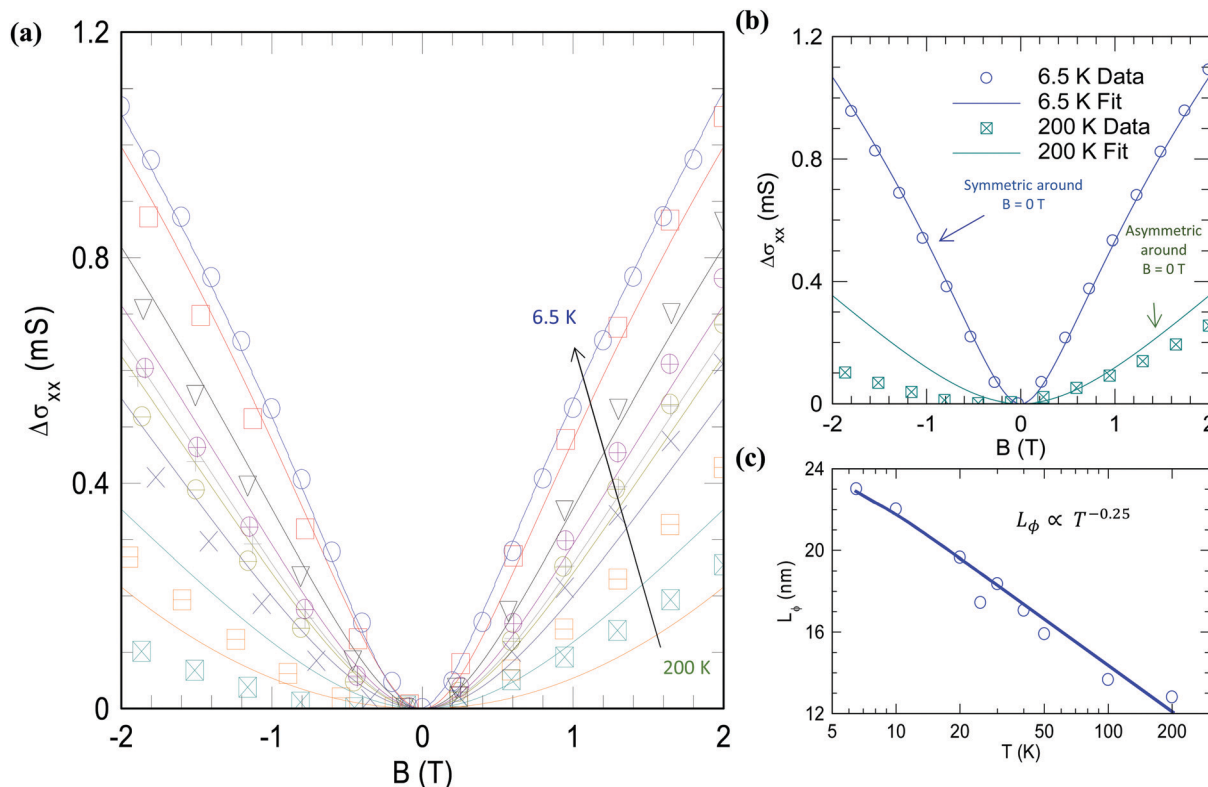


Fig. 3 Observation of weak localization. (a) $\Delta\sigma_{xx} = \sigma_{xx}(B) - \sigma_{xx}(0)$ plotted as a function of perpendicular magnetic field for various temperatures in the range of $6.5 \text{ K} < T < 200 \text{ K}$. Symbols are the data points and solid lines are fit according to the HLN model (see the text). The inset shows fitting of the data taken at $T = 6.5 \text{ K}$ and 200 K . (b) Coherence length (L_ϕ) estimated from HLN fitting of the magneto-conductance data as shown in the panel (a). Temperature dependence of L_ϕ exhibits power law, $L_\phi \propto T^{-0.25}$. Symbols are the data points and solid lines are guide to eyes.

to strong suppression in e^-e^- interactions and charge impurity scattering. This is also reflected in magneto-transport measurements where enhancement in coherence length at low temperature is observed (will be discussed later). As a consequence, conduction asymmetry, which occurs due to the scattering of relativistic carriers *via* charged impurities, will be suppressed. This qualitatively explains the temperature dependent electron-hole conduction asymmetry in our devices.

As discussed before, the presence of a Raman D peak indicates structural disorder in FLG directly grown onto SiO_2/Si substrates. To understand more about intrinsic disorder and its impact on device features, we carried out temperature dependent magneto-transport measurements. Magneto-conductance, $\sigma_{xx}(B)$, is measured in the temperature range of $6.5 \text{ K} < T < 200 \text{ K}$. Fig. 3a shows normalized magneto-conductance, $\Delta\sigma_{xx} = \sigma_{xx}(B) - \sigma_{xx}(0)$, plotted against perpendicular magnetic field, B . Strong suppression of the $\Delta\sigma_{xx}$ with magnetic field is a robust signature of the WL in our devices. This manifests that the electron weak localization originates from the constructive interference of backscattered electron wave functions which gets suppressed upon applying a perpendicular magnetic field because of the phase shift in the wave function and is consistent with the established theory and already reported results.^{15–17}

Remarkably, WL in our devices sustains till higher temperatures ($T > 200 \text{ K}$), which could be attributed to the thickness of

the graphene ($4L$). In FLG, mesoscopic corrugations, which can cause a dephasing effect (equivalent to an internal magnetic field), are substantially suppressed and inter-valley scattering is enhanced. It leads to the observed enhancement of positive conductance, resulting in the restoration of the weak localization up to relatively higher temperature.^{18–20} In order to explain the observed behaviour, we model our data with the established modified HLN model for weak localization,¹⁵ which is expressed as

$$\Delta\sigma_{xx} = \alpha \frac{e^2}{2\pi^2\hbar} \left(\psi \left(\frac{1}{2} + \frac{B}{B_\phi} \right) + \ln \left(\frac{B}{B_\phi} \right) \right) \quad (2)$$

where $B_\phi = \frac{\hbar}{4eL_\phi^2}$, ψ is the digamma function; L_ϕ , the coherence length; e , the electronic charge; \hbar , the reduced Planck's constant; and β , the empirical fitting parameter. Fitting to the data allows us to extract the characteristic length (L_ϕ) which is the dephasing length of the electrons. Fig. 3b shows the characteristic length extracted from the fits and plotted for varying temperature. L_ϕ increases with decreasing temperature and reaches up to 27 nm at 6.5 K. Temperature dependence of L_ϕ exhibits power law behaviour $L_\phi \propto T^{-0.25}$ which is consistent with previous reports for two dimensional electron gas.^{21,22} The extracted L_ϕ is less than the sample size ($5 \mu\text{m}$) to a great extent. This indicates the fact that the dominating factor of the

scattering is not the edges but rather the defects and disorders present in the sample occurring during the growth process.^{23–26} The possible defects could be the adatoms such as hydrogen impurities inevitable during the atmospheric pressure thermal CVD growth of graphene (also appeared in XPS results).

We note that magneto-transport data show good agreement with the HLN model at low temperatures. However, at $T > 50$ K, magneto-transport data could not be fully reproduced using the HLN model and fitting curves deviate from the recorded data (inset: Fig. 3a). This deviation comes with the evident asymmetry in magneto-conductance around $B = 0$ T that appears at higher temperatures. The exact origin of this temperature dependent asymmetry in the magneto-conductance is not precisely understood and requires further experimental investigation.

It is worthwhile to discuss that weak localization requires disorder in the device channel. However, in substantially disordered graphene devices, mobility should be limited by charged impurity scattering rather than due to phonons. Hence, the coexistence of WL and phonon limited mobility (Fig. 2e) is striking due to contrasting origins of these phenomena. In a work done by I. Childres *et al.*,²⁷ a similar effect in graphene devices has been reported where WL (requires disorder) and the quantum Hall effect (occurs in clean devices) were simultaneously observed. However, in a separate work by Y. Du *et al.*,²⁸ and Y. Shi *et al.*,²⁹ on black phosphorus, it is clearly demonstrated that in the regime where WL exists, carrier mobility is primarily limited due to defect scattering, *i.e.* mobility remains temperature independent. In this view, we believe that concurrence of WL and phonon limited mobility has been possible due to low disorder in directly grown graphene. This is also reflected in Hall carrier density values (10^{10} cm⁻²– 10^{12} cm⁻²) measured in our devices.

Conclusions

In conclusion, we carried out temperature dependent electrical/magneto-transport measurements on devices based on FLG grown directly on SiO₂ surfaces *via* CVD. The measured devices exhibit an intrinsic energy band-gap of 4.6 meV which causes temperature dependent electron–hole conduction asymmetry. WL and phonon limited carrier mobility have contrasting sources of origin, hence, observation of these two competing phenomena together in our devices clearly indicates the low disorder in directly grown few layer graphene. This has been verified using Raman mapping and an electron mobility of up to 600 cm² Vs⁻¹ at low temperatures. We anticipate that large area graphene layers with high quality directly grown on an insulator could provide a good platform for graphene based large scale electronics.

Author contributions

M. S. A. performed graphene growth. M. S. A. fabricated devices with the help taken from Y. H. M. S. A and P. K. S. performed electrical and magneto transport measurements, analysed data

and cowrote the manuscript. C. L. supervised the project. All authors discussed and commented on the manuscript.

Conflicts of interest

The authors declare no conflict of interest.

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